# Status of Heavy Ion Driver Point Design

Wayne Meier LLNL ARIES Meeting Oct 2, 2002 PPPL

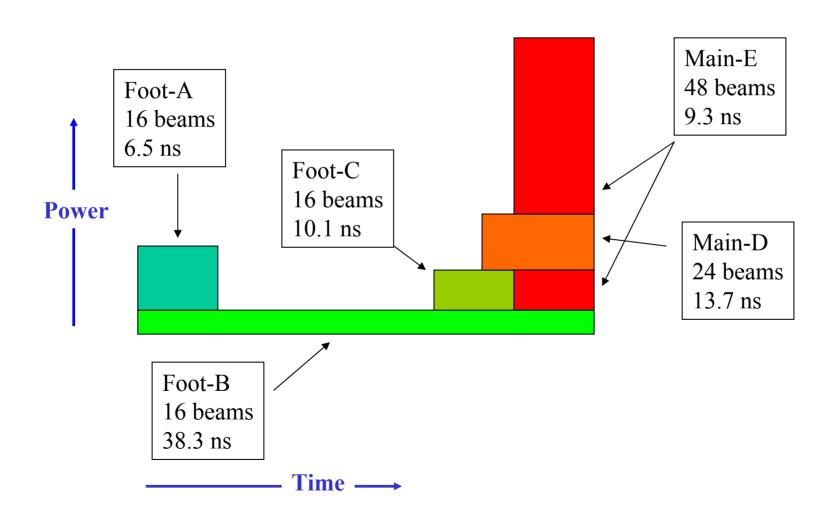
## Work continues on defining a self-consistent HI power plant design

- Since last ARIES meeting, a different approach to pulseshaping has been adopted as baseline. It requires building pulse from groups of beams with different pulse widths.
- Reference ion is now Bi (209 amu) instead of Xe (131 amu) assumed in recent previous examples
  - Better focusing capability
  - Higher driver cost
- Now referred to as the Robust Point Design (RPD) to indicate further optimization is possible.

### Some key parameters

```
Ion = bismuth (A = 209 amu)
Total beams = 120
48 foot pulse beams at 3.3 GeV
72 main pulse beams at 4.0 GeV
Total beam energy ~ 6.6 MJ (awaits 2D target calculations)
    1.8 MJ foot beams
   4.8 MJ main pulse beams
Beam focus half angle = 10 \text{ mrad}
Spot size \sim 2 \text{ mm} at focal length = 6 m
   Meets requirements of distributed radiator target
```

#### Illustration of pulse shape – beam power vs. time



#### **Summary**

- Appears to be agreement on current choice of baseline parameters for RPD driver, chamber, target.
- This point will serve basis for more detailed design work and analyses (magnet packing, focusing, shielding, costing, etc.)
- Several papers planned for ANS Technology of Fusion Energy meeting in November

#### **Future work**

- HIF VNL and VLT funded work will continue on all aspects of HIF
- ARIES participants can contribute to continued design optimization processes
- LLNL will continue work on
  - Driver and power plant systems code improvements and systems analyses
  - Final focus magnet shielding coupled with VNL magnet design and layout and chamber fluid configuration (details in Latkowski talk)
  - Chamber and magnet mechanical design (nozzles, first wall, magnet support (with PPPL), materials issues)
  - Target design (VNL funded)